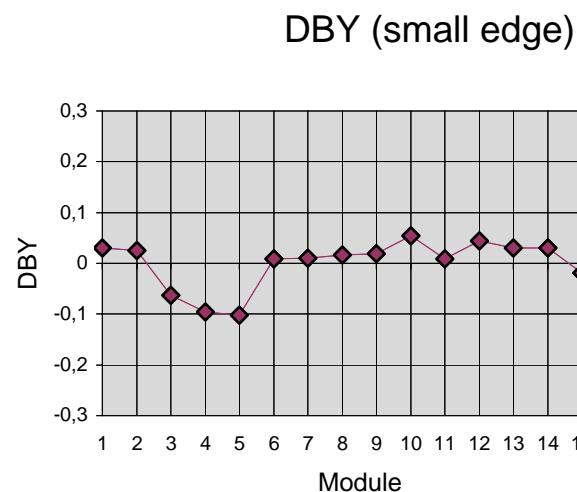
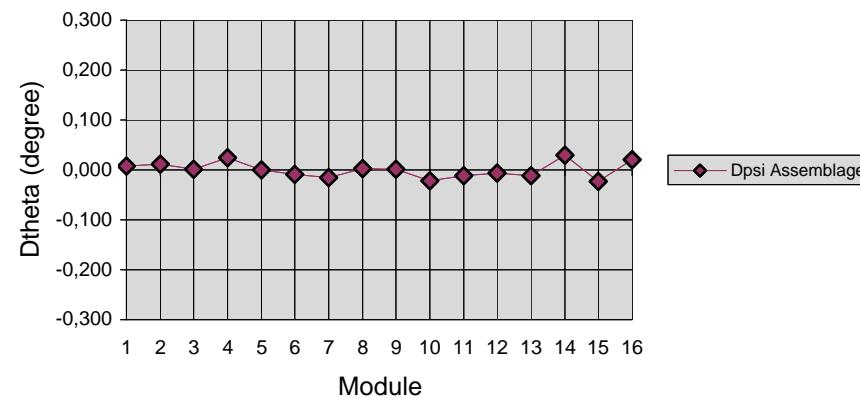


Rotation in the wafer plane



Ass. Order	19
Lad	17
Position	Run IV
	99
	Run V
	4
	Run VI
	4

Module 3 shifted by 100 microns in Y
 Module 4 shifted by 100 microns in Y
 Module 5 shifted by 100 microns in Y